

## Supporting Information

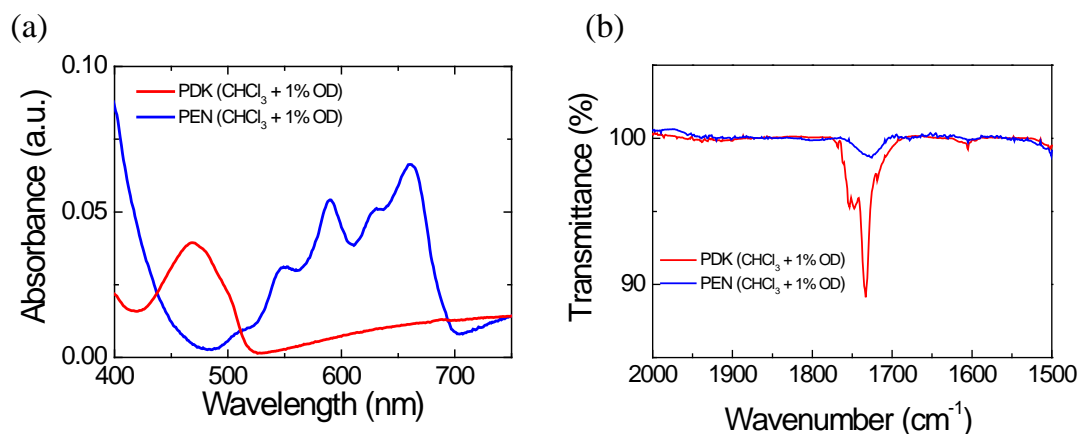
### Characterization and Field-Effect Transistor Performance of Printed Pentacene Films Prepared by Photoconversion of the Soluble Precursor

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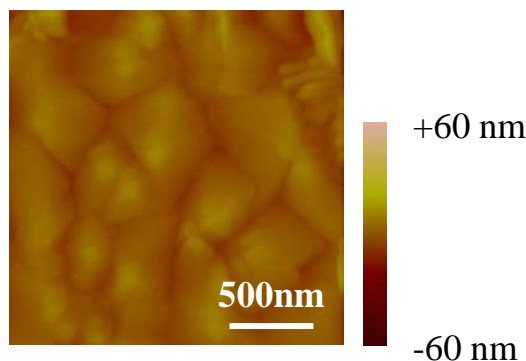
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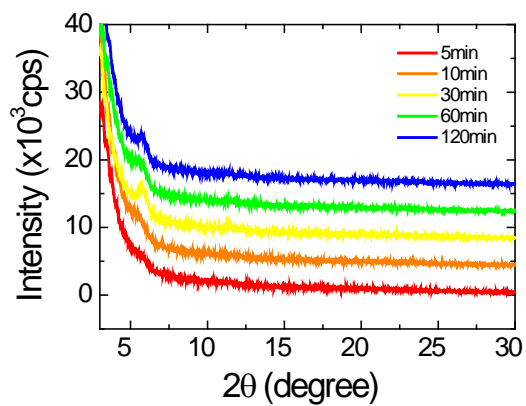
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**Figure S1.** (a) UV/vis spectra and (b) FT-IR/ATR spectra, for the PDK films spin-coated from chloroform solution with 1% 1,8-octanedithiol before and after photoirradiation.



**Figure S2.** AFM image of a vacuum-deposited pentacene film on a HMDS-treated Si/SiO<sub>2</sub> substrate. The surface roughness RMS value was 6.7 nm.

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**Figure S3.** XRD patterns of photoconverted pentacene films with various photoirradiation times. **PDK** films were prepared from chloroform with 1% TCB on GR650-treated Si/SiO<sub>2</sub> substrates.